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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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PRIORITY Application Serial No.08/996,325
PRIORITY Filing Date December 22, 1997
Inventor H. Montgomery Manning
Assignee Micron Technology, Inc.
PRIORITY Group Art Unit 2822
PRIORITY Examiner M. Trinh
Attorney's Docket No. MI22-1698
Title: Methods of Forming Thin Film Transistors

Rel
3-25-03

PRELIMINARY AMENDMENT BEING FILED WITH A DIVISIONAL
APPLICATION

To: Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

Please enter the following amendments prior to examining the above-
identified application.

0992097-080101